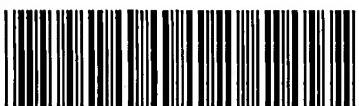


Search Notes	Application/Control No.	Applicant(s)/Patent Under Reexamination
	10666309	CREAMER ET AL.
Examiner	Art Unit	
Park, Jeong S	2109	

SEARCHED

Class	Subclass	Date	Examiner
709	224	4/2/2007	Jeong Park

SEARCH NOTES

Search Notes	Date	Examiner
limited text search of 709/224 with terms of "monitoring or monitored", "system", "behavior or pattern", "web"	4/2/2007	Jeong Park
limited text search of 709/224 with terms of "monitoring or monitored", "system", "behavior", "multiple or plurality"	4/5/2007	Jeong Park
Text search with terms of "computing resource", "web server"	9/6/2007	Jeong Park
Text search with terms of "monitoring or monitor or monitored", "grid", "computing resource"	9/6/2007	Jeong Park

INTERFERENCE SEARCH

Class	Subclass	Date	Examiner